

FORM PTO-1449 COMMERCE (REV. 7-80)	U.S. DEPARTMENT OF PATENT AND TRADEMARK OFFICE	ATTY. DOCKET NO. TI-22166	SERIAL NO. 08/988,686
LIST OF DOCUMENTS CITED BY APPLICANT (Use several sheets if necessary)		APPLICANT Konecni, et al.	
		FILING DATE 12/11/97	GROUP TBD



U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE (IF APPROPRIATE)
KE	AA	5,043,299	8/27/91	Chang, et al.	437	192	12/1/89
KE	AB	5,252,181	10/21/93	Dutartre, et al.	156	651	12/17/91
	AC						
	AD						
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	AG						
	AH						
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	AJ						
	AK						

FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION
							YES NO
KE	AL	EP 0 370 775 A	5/30/90	Europe	H01L	21/90	Yes
	AM						
	AN						

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)		
KE	AR	Patent Abstracts of Japan, Vol. 013, No. 069 (C-569), 16 February 1989 & JP 63 262473 A, 29 Oct. 1988 *abstract* (Mitsubishi Electric Corp)
KE	AS	Patent Abstracts of Japan, Vol. 016, No. 475 (E-1273), 2 October 1992 & JP 04 171744 A, 18 June 1992 *abstract* (Mitsubishi Electric Corp)
KE	AT	Patent Abstract of Japan, Vol. 017, No. 044 (E-1312), 27 January 1993 & JP 04 259218A, 14 September 1992 *abstract* (Matsushita Electric Ind Co LTD)
KE	AU	Patent Abstract of Japan, Vol. 014, No. 470 (C-0769), 15 October 1990 & JP 02 194179 A, 31 July 1990 *abstract* (Ishikawajima Harima Heavy Ind. Co. LTD)
KE	AV	Takeyasu, N., et al., "Characterization of Direct-Contact Via Plug Formed by Using Selective Aluminum Chemical Vapor Deposition" Japanese Journal Of Applied Physics, Vol. 33, No. 1B, Part 01, 1 January 1994, Pgs. 424-428

EXAMINER K. J. EATON	DATE CONSIDERED 5/7/99
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.